

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Yasuo KOBAYASHI, et al. **Confirmation No.: 7185**

U.S. Serial No. : 10/549,859

Filed : June 6, 2006

Examiner : Michael G. Miller

Group Art Unit : 1792

For : PLASMA-ASSISTED DEPOSITION METHOD AND PLASMA-ASSISTED DEPOSITION SYSTEM

AMENDMENT PURSUANT TO RULE 111

MAILSTOP: AMDT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed February 23, 2010, to which a response was due May 23, 2010, please consider the amendments and remarks as set forth below. A Petition for a Third Month Extension of Time, together with the requisite fee, is enclosed to extend the response due date to August 23, 2010.

Amendments to the Claims begin on page 2.

Remarks begin on page 5.